

ITW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/797,046

Filing Date: March 11, 2004

Applicant: Jung-Hyun LEE et al.

Group Art Unit: 2811

Examiner: Ori Nadav

Title: METHOD FOR MANUFACTURING OXIDE FILM
HAVING HIGH DIELECTRIC CONSTANT,
CAPACITOR HAVING DIELECTRIC FILM
FORMED USING THE METHOD, AND METHOD
FOR MANUFACTURING THE SAME

Attorney Docket: 2557SI-001239/us

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop AF

September 21, 2009

STATEMENT UNDER 37 C.F.R. § 1.133(b)

Sir:

In response to the telephonic interview conducted on August 17, 2009 and the Interview Summary dated August 21, 2009, the following remarks are respectfully submitted in connection with the above-identified application.

Interview Summary

Applicants wish to thank the Examiner for the courtesies extended

during the telephonic interview conducted on August 17, 2009.

Applicants have reviewed the Interview Summary and have found it to be substantially accurate in its description of the substance of the interview.

CONCLUSION

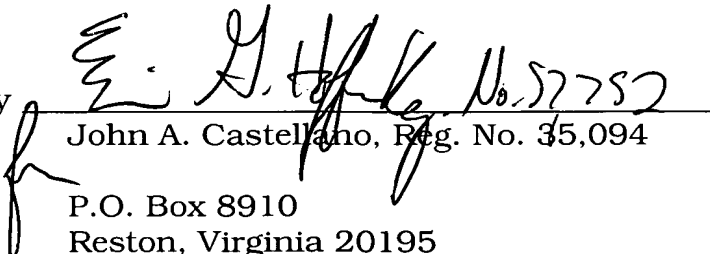
Should there be any outstanding matters that need to be resolved in the present application; the Examiner is respectfully requested to contact the undersigned at the telephone number of the undersigned below.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

HARNESS, DICKEY, & PIERCE, P.L.C.

By


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